

Delphi-X Inverso

for materials science

HIGHLIGHTS

- · Materials science applications
- · Observation of materials science samples
- · Brightfield, dark field, polarization
- · DIC (differential interference contrast)
- · Long working distance IOS plan semi apochromatic objectives
- · Revolving sextuple nosepiece
- · 100 W halogen reflected illumination

TECHNICAL SPECIFICATIONS

EYEPIECES

Pair of DIN HWF plan 10x/22 mm

HEAD

- Trinocular 45° inclined tubes
- Interpupillary distance of 47 to 78 mm
- Trinocular head with 100-0, 80/20 and 0/100 positions
- · Built-in Bertrand lens

NOSEPIECE

Revolving sextuple nosepiece on ball-bearings. With DIC slot

OBJECTIVES - 45 MM PARFOCAL

High numerical, infinity (Semi-)apochromatic bright-/darkfield objectives. Long working distance, IOS, no cover glass correction, M26 mount

- Plan Semi-Apochromatic (PL-SAMi): 5x/0.15 WD 20 mm, 10x/0.30 WD 11 mm, 20x/0.45 WD 3.1 mm
- Plan Apochromatic (PL-AMi): 50x/0.80 WD 1 mm and optional 100x/0.90 WD 1 mm

Optional:

 DI.8100: Plan Apochromatic (PL-AMi) 100x/0.90 IOS BD objective, WD 1 mm, no coverglass correction, 45 mm parfocal, M26 mounting thread
WD = working distance

All optics are anti-fungus treated and anti-reflection coated for maximum light throughput





DI.2053-PLMI

414.5 (h) x 385 (w) x 627.5 mm (d) | 29 kg

STAGE

Stage 340 x 230 mm, equipped with a coaxial mechanical 130 x 85 mm X-Y stage

Supplied with:

- Metal insert with hole ø 20 mm
- Metal insert with hole ø 28 mm
- Metal insert with drop-shaped hole

Maximum weight for sample: 30 kg

MAGNIFICATION CHANGER

A magnification changer with a 1.5x lens allows intermediary magnifications of 1.5 times the standard objective magnifications. For example, switching from 20x or 50x to 30x to 75x magnification can be done without the need to change objectives

MULTIFUNCTIONAL WHEEL

The Delphi-X Inverso has a 6-position multifunctional wheel, supplied with cubes for two brightfield, one darkfield and one polarization filter. Slider with prisms for the 5x/20x and 50x/100x magnifications and slider with analyzer. See photo 1 next page

Bertrand lens and trino/eyepieces selector



ADDITIONAL SLIDER SLOTS

Besides a field diaphragm and condenser aperture, two slots are available. A slider with two neutral density filters is also supplied. See photo 2

FOCUS ADJUSTMENT

Low positioned coaxial with 10 mm coarse and fine adjustments focusing knobs, 1 μm precision and with friction adjustment

CAMERA PORTS

Beside the standard photo port of the head, there are two other photo parts at both both left and right side of the microscope. See photo 3

ILLUMINATION

reflected 100 W halogen Intensity adjustable with internal 100-240 V power supply. Fuse holder 1 A / 250 V







MODEL	Trino	LWD Plan Semi-Apo 5/10/20x	LWD Plan Apo 50x	LWD Plan Apo 100x	100 W Halogen illumination	DIC
DI.2053-PLMI	•	•	•	0	•	0
o = optional						

DELPHI-X INVERSO | v.428401 2/3



ACCESSOIRES

EYEPIECES

Ø 30 mm

DI.6010 Super wide field SWF 10x/25 mm f ocusable eyepiece for

Delphi-X Inverso

DI.6010-C Super wide field SWF 10x/25 mm eyepiece

with crosshairs

DI.6010-M Super wide field SWF 10x/25 mm eyepiece

with micrometer

DI.6010-CM Super wide field SWF 10x/25 mm eyepiece

with micrometer and crosshairs

DI.6010-SG Super wide field SWF 10x/25 mm eyepiece

with 20 x 20 square grid reticle

DI.6210 Super wide field SWF 10x/22 mm focusable eyepiece for

Delphi-X Inverso

DI.6012 Wide field WF 12.5x/17.5 mm eyepiece

for Ø 30 mm tube for Delphi-X Inverso

DI.6015 Wide field WF 15x/16 mm eyepiece

for Ø 30 mm tube for Delphi-X Inverso

DI.6020 Wide field WF 20x/12 mm eyepiece

for Ø 30 mm tube for Delphi-X Inverso

DI.6099-L Eyeshade for eyepieces

OBJECTIVES 45 MM PARFOCAL

M26 mounting thread, no cover glass correction

DI.8105 Infinity Plan Semi-Apochromatic PL-SAMi 5x/0.15 IOS BD

objective, working distance 20 mm

DI.8110 Infinity Plan Semi-Apochromatic PL-SAMi 10x/0.30 IOS BD

objective, working distance 11 mm

DI.8120 Infinity Plan Semi-Apochromatic PL-SAMi 20x/0.40 IOS BD

objective, working distance 3.1 mm

DI.8150 Infinity Plan Apochromatic PL-AMi 50x/0.80 IOS BD objective,

working distance 1 mm

DI.8100 Infinity Plan Apochromatic PL-AMi 100x/0.90 IOS BD objective,

working distance 1 mm

BD = brightfield/darkfield

DIFFERENTIAL INTERFERENCE CONTRAST (DIC)

DI.9696 Differential interference contrast set (DIC). Includes two DIC

prisms and a DIC analyzer for 5x upto 20x objectives

DI.9691-52 DIC prism for nosepiece of materials science Delphi Inverso

model. To be used with Plan Semi-Apochromatic 5x/20x

DI.9691-51 DIC prism for nosepiece of materials science Delphi Inverso

models. To be used with Plan Apochromatic 50x/100x

DI.9698 DIC analyzer for nosepiece for Delphi-X Inverso

MISCELLANEOUS

DI.9810 C-mount with 1x magnification for 1 or 2/3 inch C-mount

DI.9840 C-mount with 0,4x magnification for 1/3 inch C-mount camera DI.9850 C-mount with 0,5x magnification for 1/2 inch C-mount camera







DI.6210

DI.9840











Objectives





